

<b>Search Notes</b>	<b>Application/Control No.</b>	<b>Applicant(s)/Patent Under Reexamination</b>
	10574052	TAKAHASHI ET AL.
	<b>Examiner</b> Lucas Stelling	<b>Art Unit</b> 1797

### SEARCHED

<b>Class</b>	<b>Subclass</b>	<b>Date</b>	<b>Examiner</b>
210	748+, 749, 760, 761, 765, 766, 167.01, 194, 195.1, 198.1, 205,	2/18/2010	/LS/
261	76, 94	2/18/2010	/LS/
366	336, 340, 174.1, 175.2,	2/18/2010	/LS/
138	40, 41	2/18/2010	/LS/

### SEARCH NOTES

<b>Search Notes</b>	<b>Date</b>	<b>Examiner</b>
inventor name search in eDAN	2/18/2010	/LS/
keywords used – microbubble, nanobubble, cavitation, micron, nozzle,	2/18/2010	/LS/
search updated	11/16/2010	/LS/

### INTERFERENCE SEARCH

<b>Class</b>	<b>Subclass</b>	<b>Date</b>	<b>Examiner</b>

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